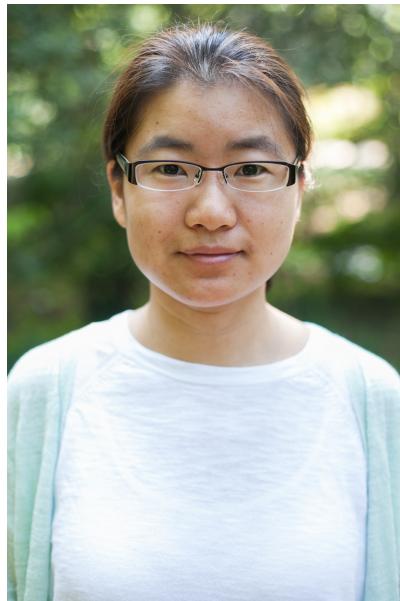




SCHOOL *of* ENGINEERING & APPLIED SCIENCE
UNIVERSITY *of* VIRGINIA

Semiconductor thermal conductivity measurements using FDTR/TDTR without a metal transducer



Lei Wang, Ph.D.

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Associate Professor

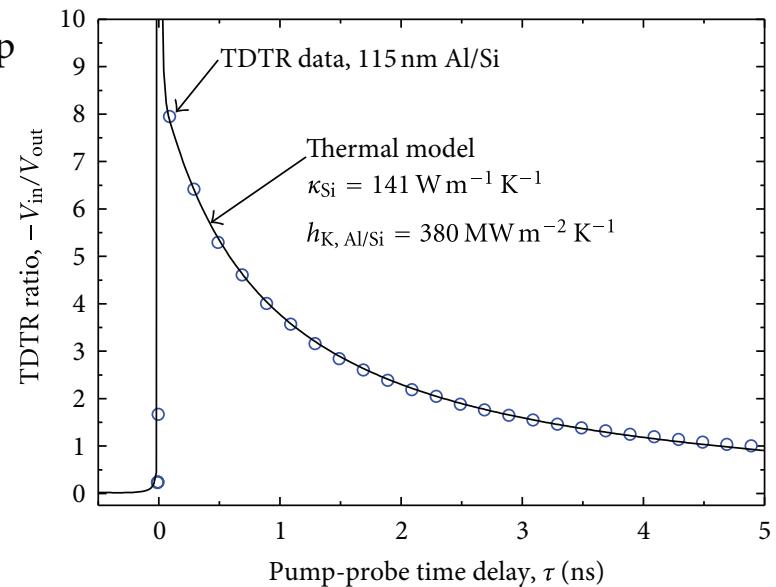
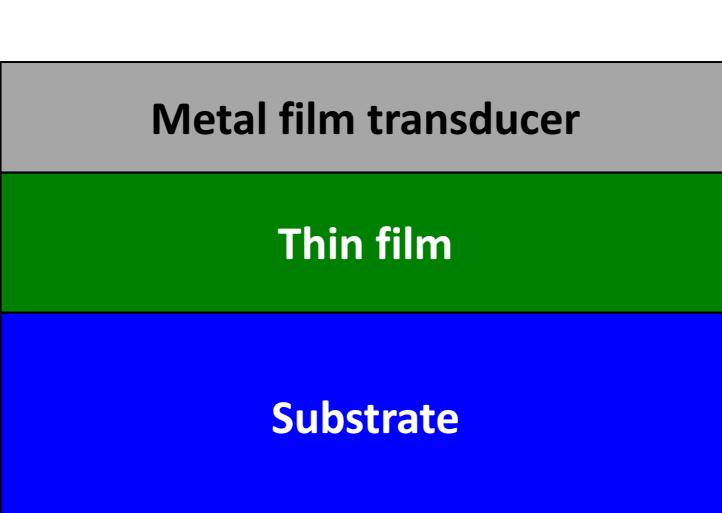
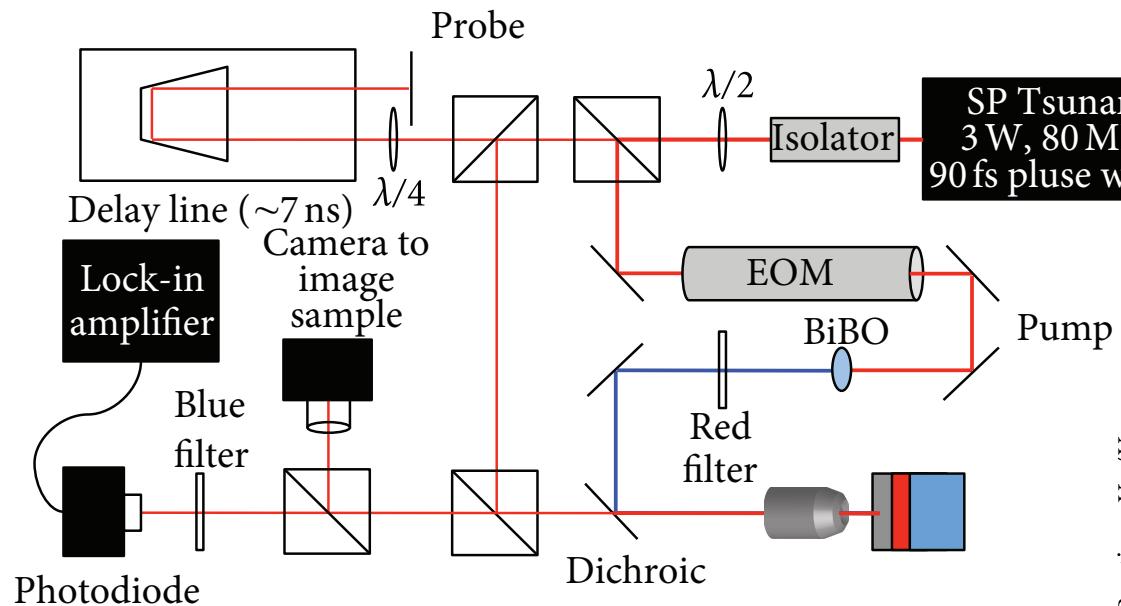
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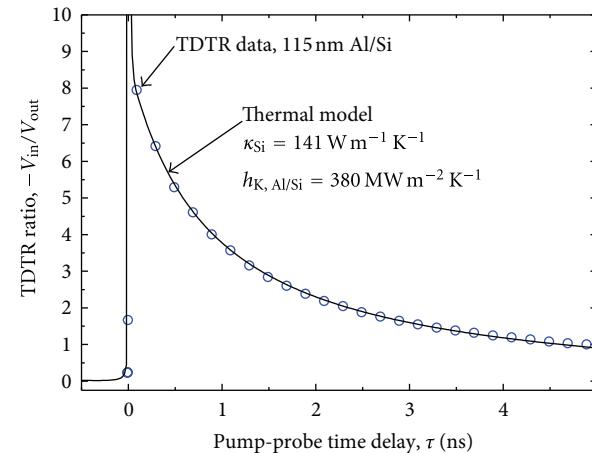
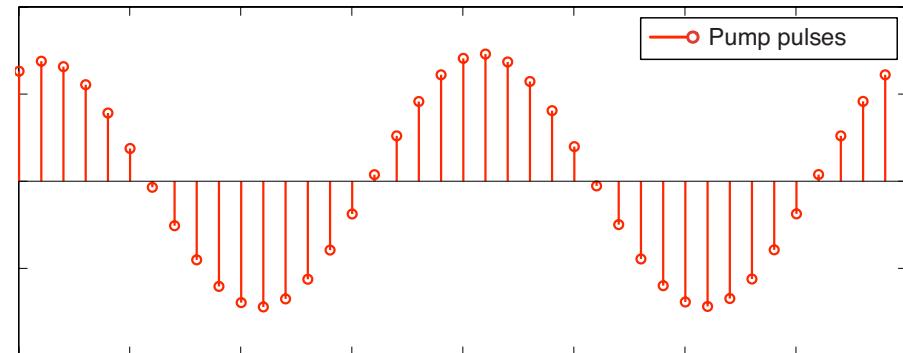
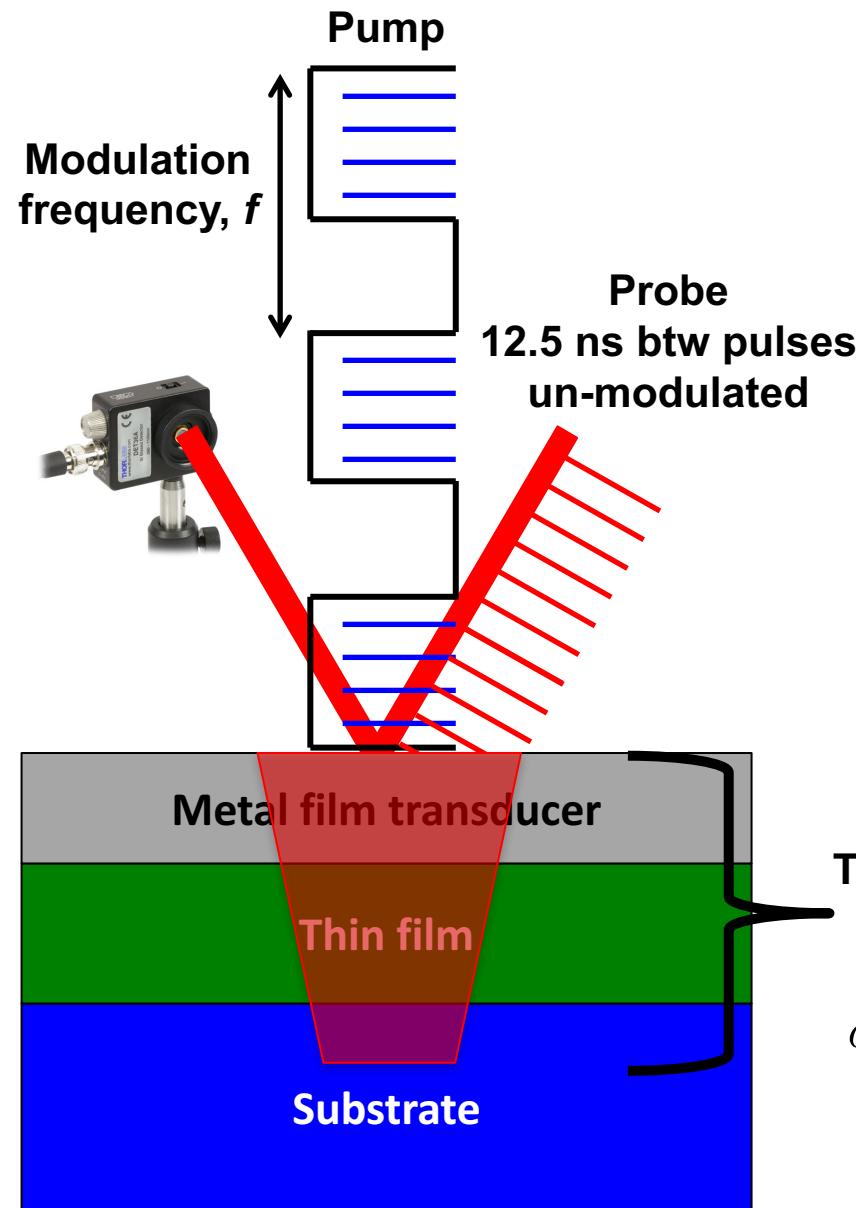
The “standard” TDTR/FDTR detection/configuration



TDTR Reviews and Analyses

Rev. Sci. Instr. **75**, 5119
Rev. Sci. Instr. **79**, 114902
J. Heat Trans. **132**, 081302
Ann. Rev. Heat Trans. **16**, 159

The “standard” TDTR/FDTR detection/configuration



Thermal penetration depth
“Measurement volume”

$$\delta_{\text{thermal}} = \sqrt{\frac{\kappa}{\pi C f}}$$

TDTR Reviews and Analyses

Rev. Sci. Instr. **75**, 5119

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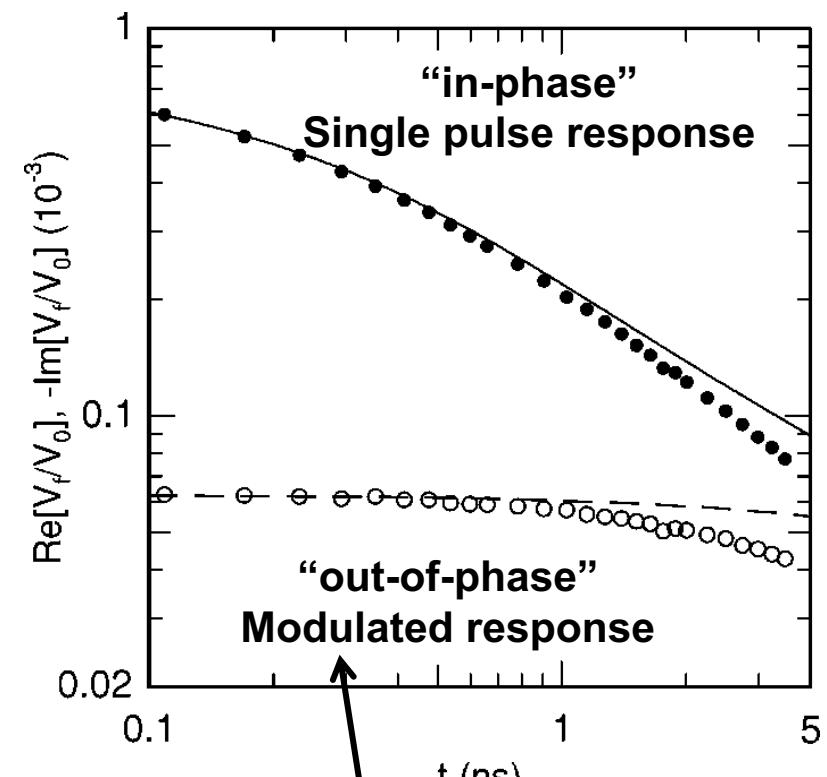
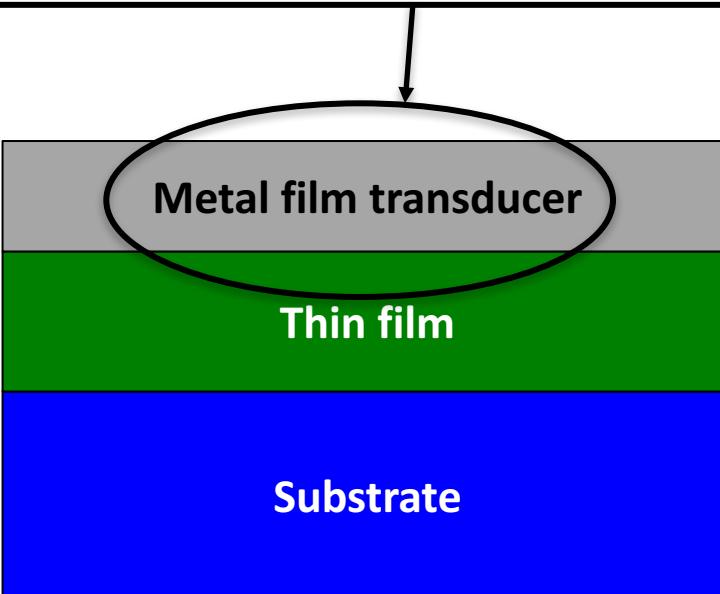
J. Heat Trans. **132**, 081302

Ann. Rev. Heat Trans. **16**, 159

The “standard” TDTR/FDTR detection/configuration

Why?

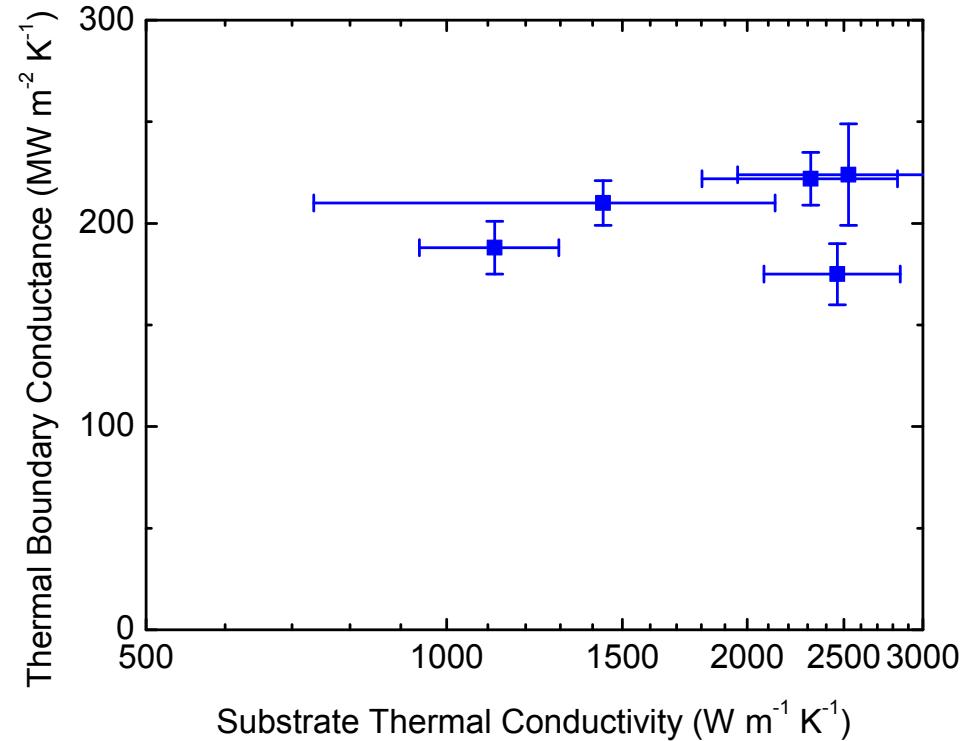
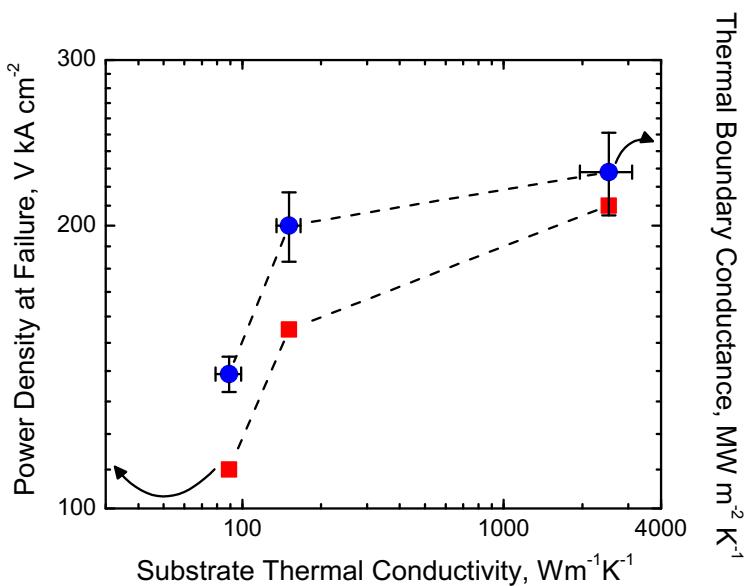
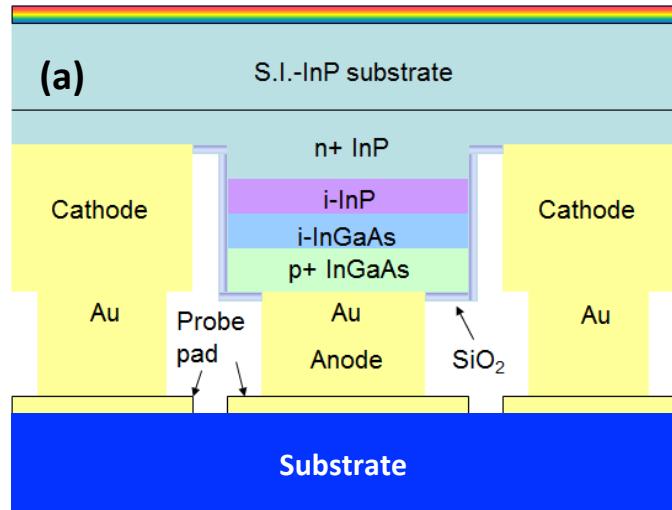
- 1) Spatial resolution
~10 nm absorption depth using wavelengths typical in TDTR
- 2) Reflectivity ~ temperature
 - Electronic thermalization in metals is fast (~ps)
 - NOT necessarily case for non-metals



Most of the information/sensitivity to thermal conductivity

Some issues that have arisen with the metal transducer

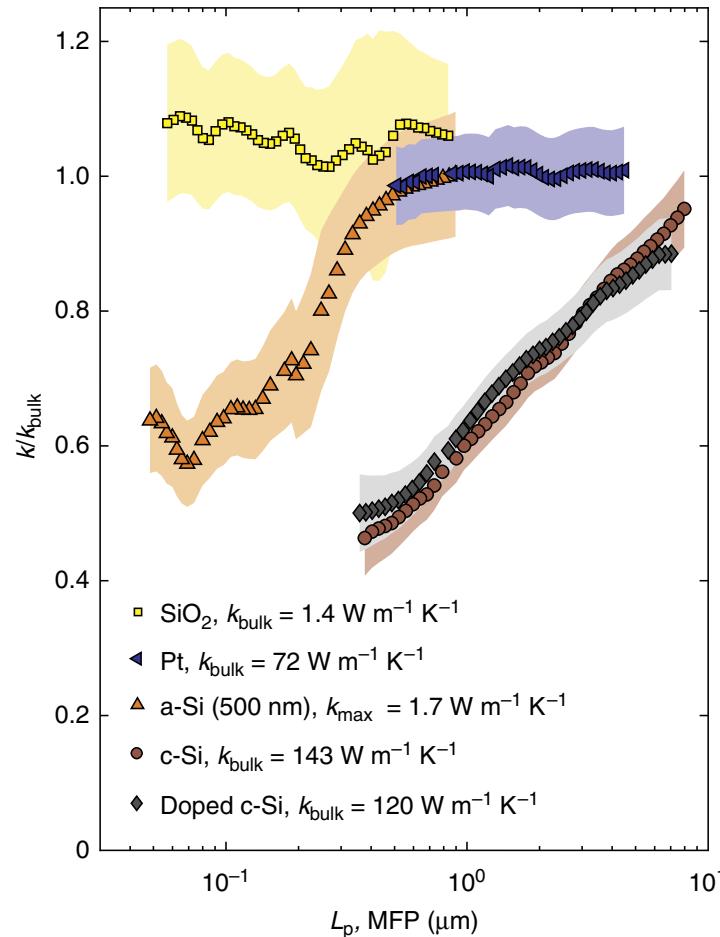
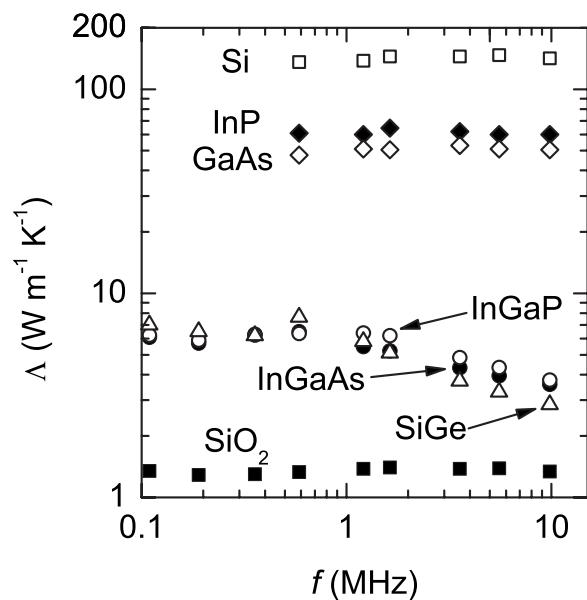
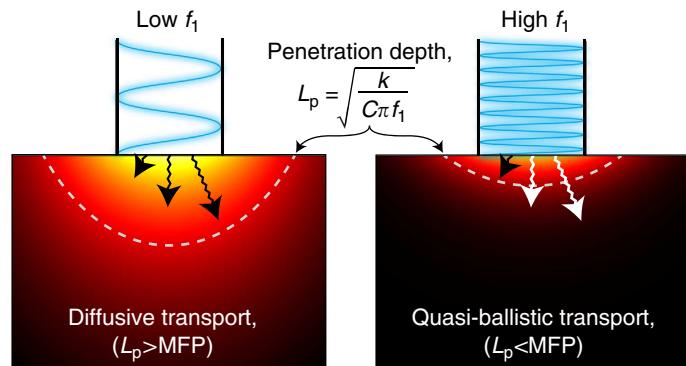
Sensitivity to thermal conductivity of high κ substrates



It's hard to measure thermal conductivity of high κ substrates with TDTR with TBC is too low!

Some issues that have arisen with the metal transducer

“Mean free path spectroscopy” based on modulation frequency



Some issues that have arisen with the metal transducer

PHYSICAL REVIEW B **90**, 064302 (2014)

Analytical interpretation of nondiffusive phonon transport in thermoreflectance thermal conductivity measurements

K. T. Regner,¹ A. J. H. McGaughey,^{1,2} and J. A. Malen^{1,2,*}

PHYSICAL REVIEW B **88**, 144305 (2013)

Two-channel model for nonequilibrium thermal transport in pump-probe experiments

R. B. Wilson,^{*} Joseph P. Feser, Gregory T. Hohensee, and David G. Cahill

ADVANCES IN STUDYING PHONON MEAN FREE PATH DEPENDENT CONTRIBUTIONS TO THERMAL CONDUCTIVITY

Keith T. Regner¹, Justin P. Freedman²,
and Jonathan A. Malen^{1,2}

ARTICLE

Received 3 Dec 2013 | Accepted 26 Aug 2014 | Published 1 Oct 2014

DOI: 10.1088/ncomms6075

Anisotropic failure of Fourier theory in time-domain thermoreflectance experiments

R.B. Wilson¹ & David G. Cahill¹

PHYSICAL REVIEW B **90**, 205412 (2014)

Nonlocal theory for heat transport at high frequencies

Yee Kan Koh,^{1,2} David G. Cahill,² and Bo Sun¹

Discussion items in above works

- Standard thermal conductivity analyses can fail
- Spectrum of phonons “launched” into substrate affects measured κ (e.g., metal film, nonequilibrium)

Can we use TDTR/FDTR w/o a transducer?

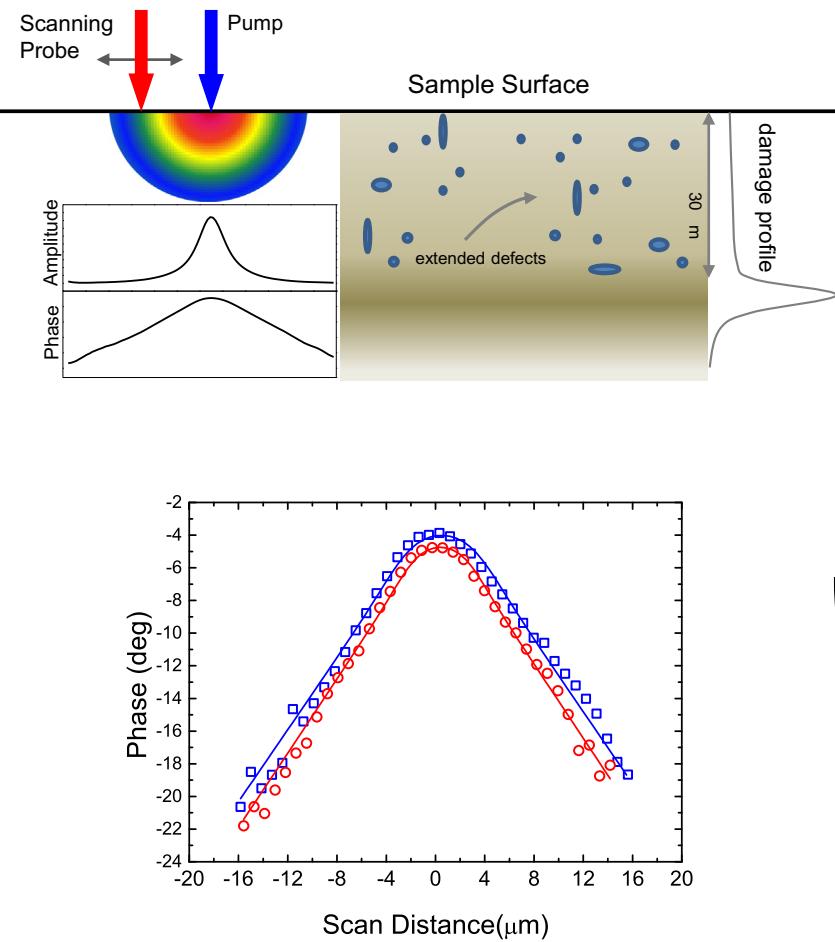
- Previous works
 - Well established in frequency domain (Opsal, Christofides, Mandelis, and Othonos)
 - Recently: Aaron Schmidt and David Hurley
 - Thermal vs. plasma effects – incorporating the “standard” TDTR procedure and analysis
- Combined FDTR/TDTR – using the time domain data
- Bulk system measurements and uncertainty

Key Challenge

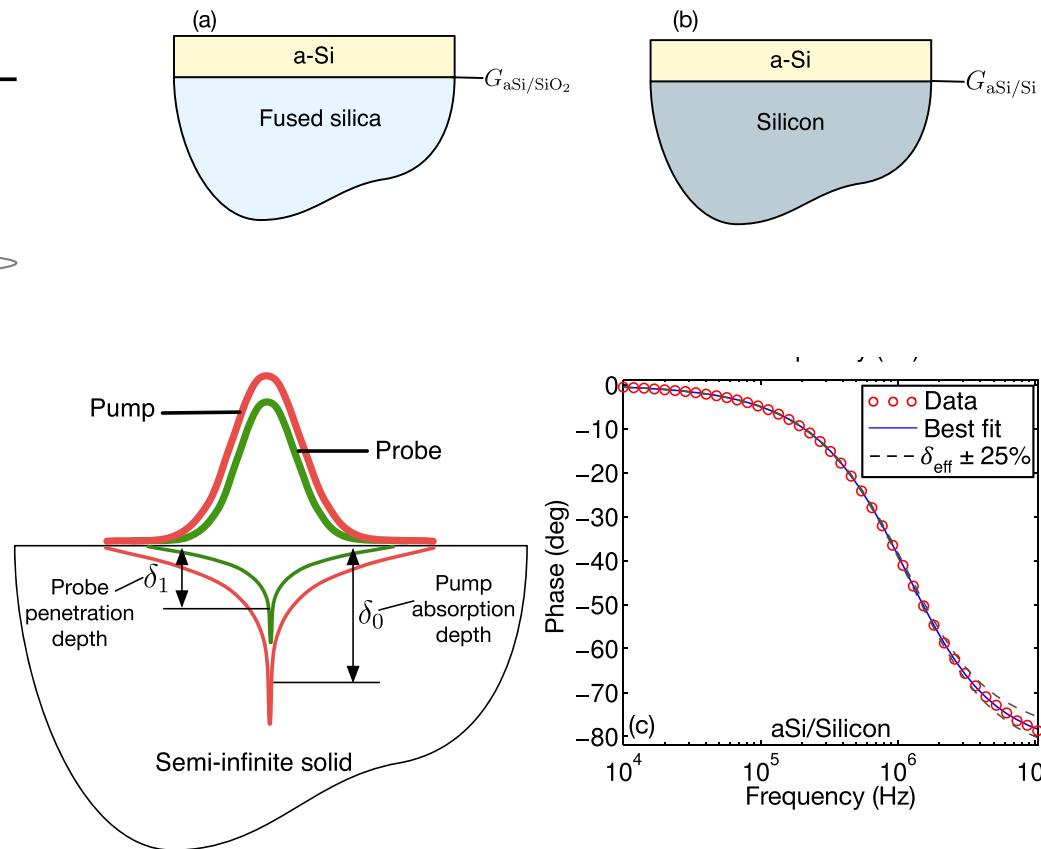
- Need **photothermoreflectance** signal to be dominated by temperature
- Ensure **photothermoreflectance** is pure **thermoreflectance**

Recent works using thermorelectance w/o metal films

Beam offset
Nuclear Inst. Meth. Phys. Res. B **325**, 11 (2014)

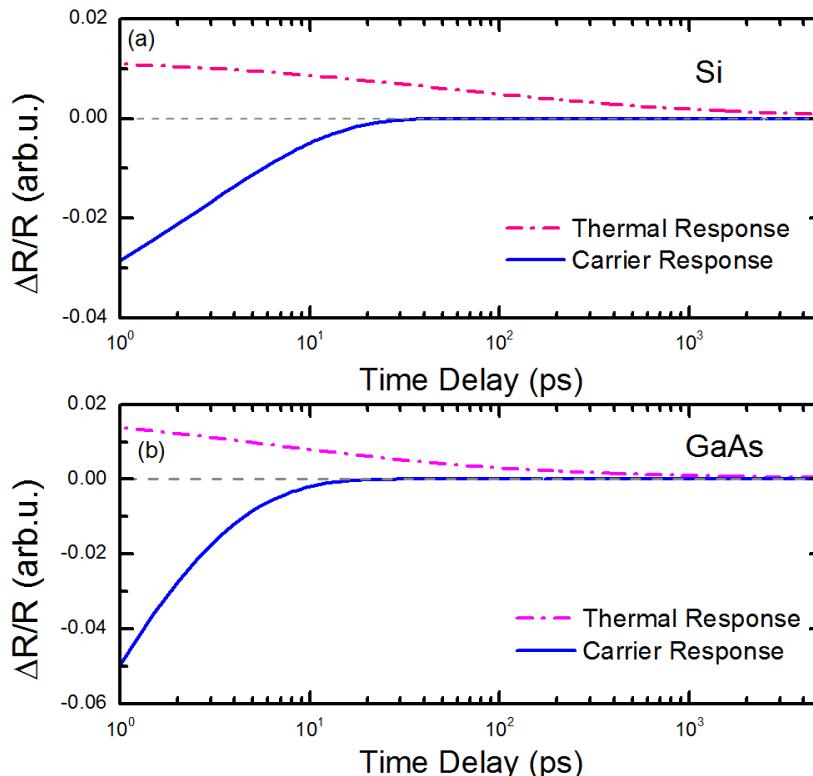


Standard FDTR with non-surface source
JAP **119**, 095107 (2016)



Thermal vs. plasma effects – separate in the time domain

Coupled thermal/plasma model
When is plasma contribution negligible?
(JAP 82, 4033 (1997))



$$\Delta R = \frac{\partial R}{\partial T} \Delta T + \frac{\partial R}{\partial N} \Delta N$$

REVIEW OF SCIENTIFIC INSTRUMENTS 87, 094902 (2016)

Thermal conductivity measurements of non-metals via combined time- and frequency-domain thermoreflectance without a metal film transducer

L. Wang, R. Cheaito, J. L. Braun, A. Giri, and P. E. Hopkins

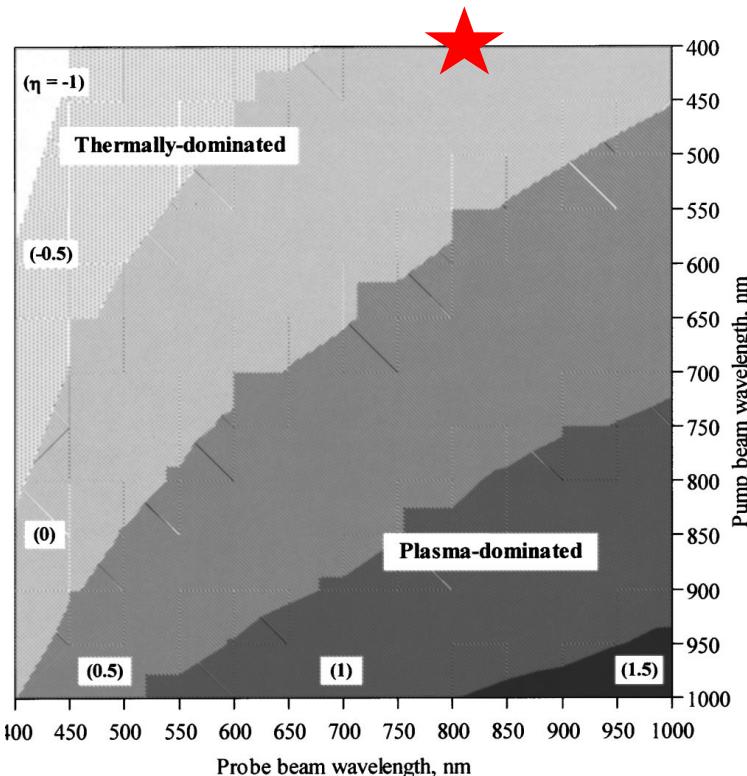
Department of Mechanical and Aerospace Engineering, University of Virginia,
Charlottesville, Virginia 22904, USA

Thermal vs. plasma effects – pump/probe wavelengths

Coupled thermal/plasma model

When is plasma contribution negligible?

(*RSI* **74**, 545 (2003), *JAP* **67**, 15 (1990))



$$\Delta R = \frac{\partial R}{\partial T} \Delta T + \frac{\partial R}{\partial N} \Delta N$$

Net photothermal reflectance signal

$\omega\tau \ll 1$

$\omega\tau \gg 1$

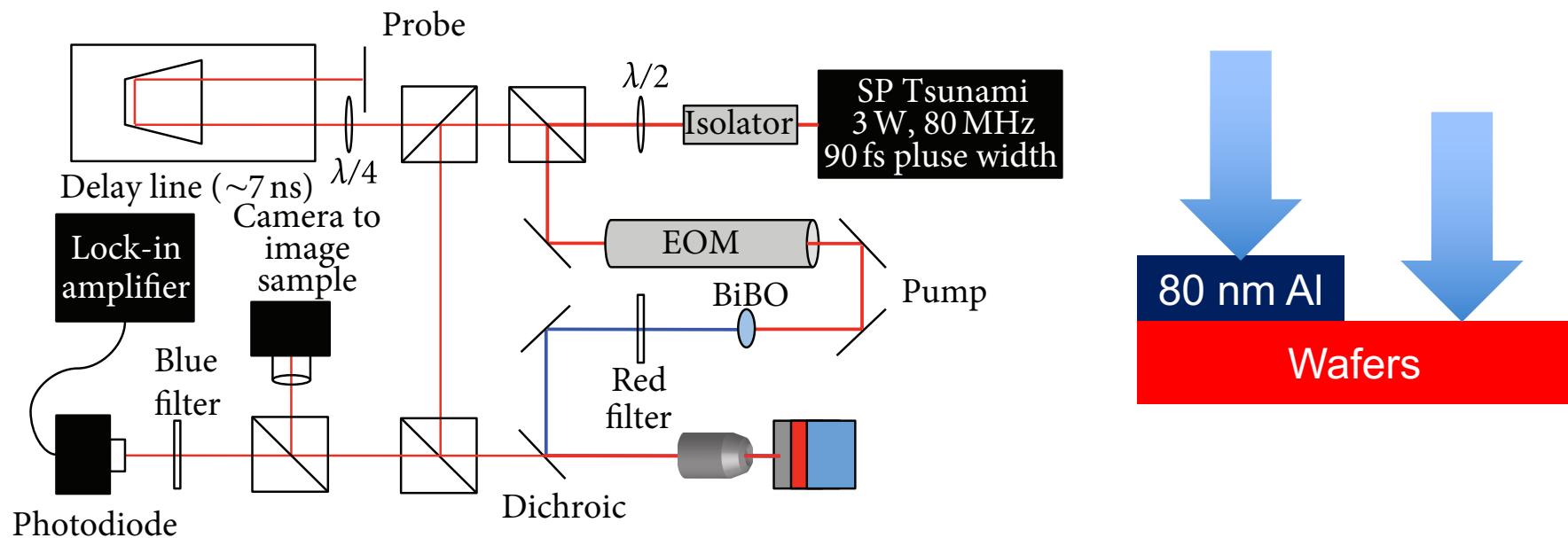
Thermal

Thermal + Plasma

Key Experimental Design

- Low modulation frequency
- Short plasma relaxation time

Standard TDTR/FDTR – with and without metal transducer



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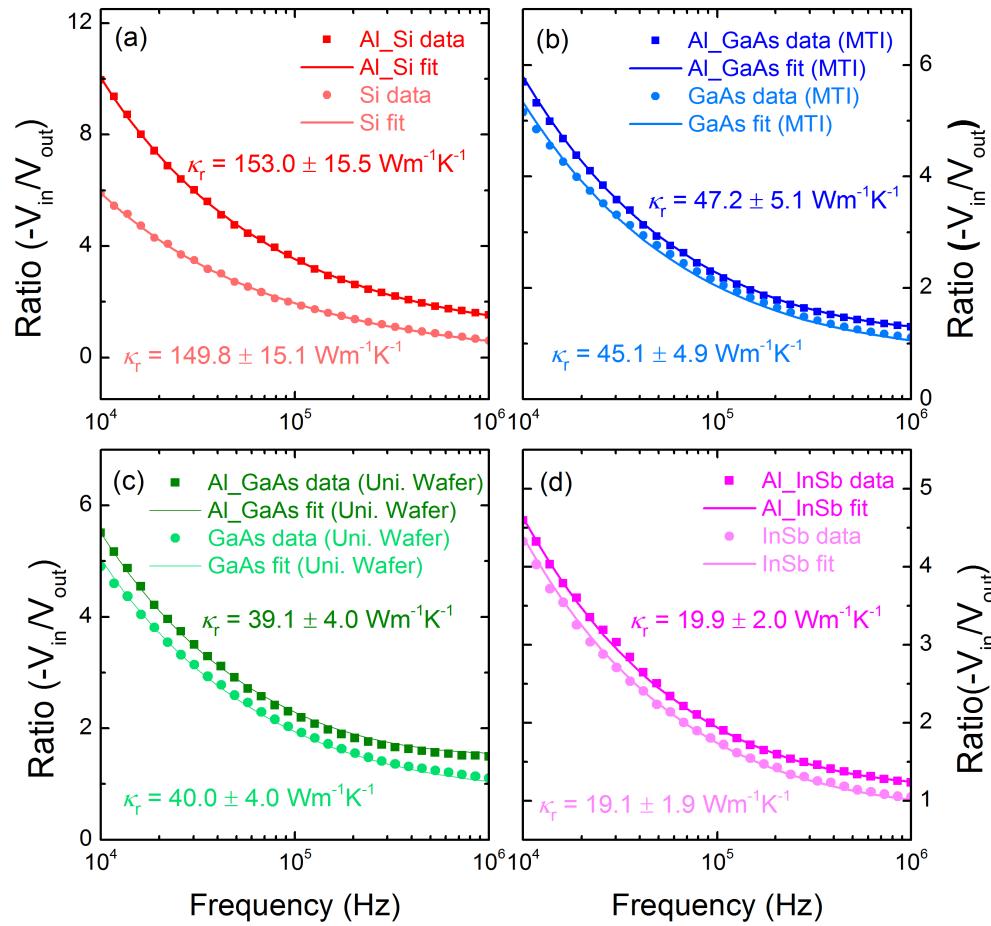
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Key Experimental Design

- Low modulation frequency: FDTR below 1 MHz
- Short plasma relaxation time: 400 nm pump, FDTR @ 5 ns delay

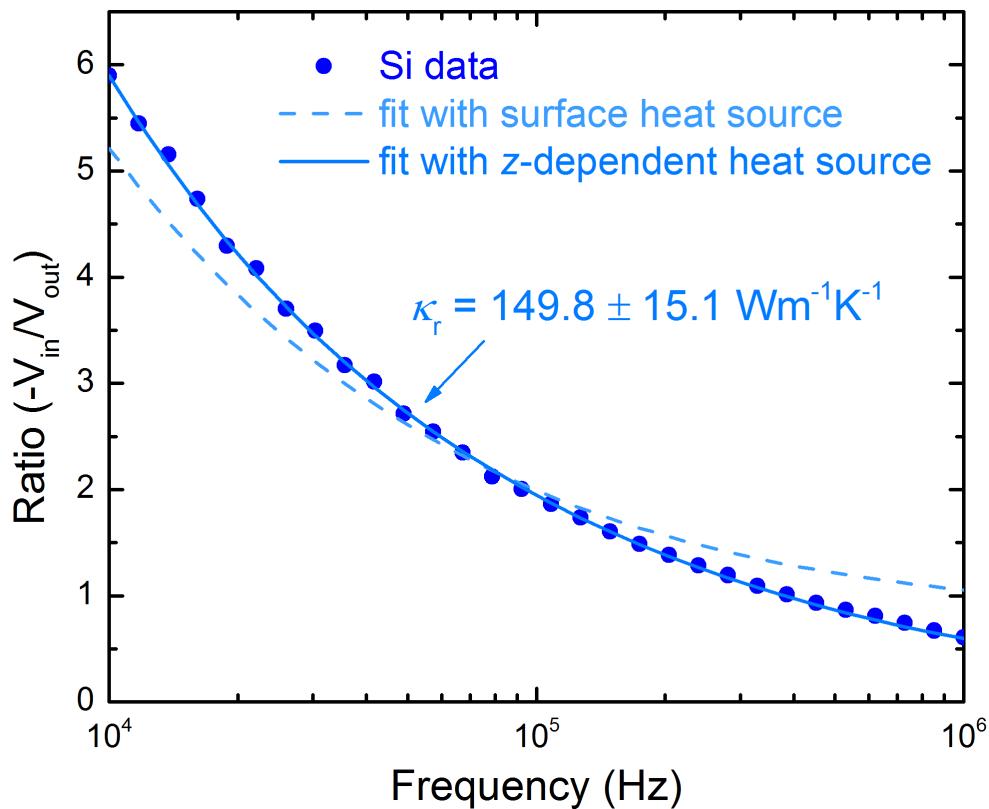
Standard TDTR/FDTR – with and without metal transducer



Key Experimental Design

- Low modulation frequency: FDTR below 1 MHz
- Short plasma relaxation time: 400 nm pump, FDTR @ 5 ns delay

z-dependent source important in Si at these wavelengths



Probe optical penetration depth
 $\delta_{Si} = 9.73 \mu\text{m}$ (800 nm)

Pump optical/heat source penetration depth
 $\zeta_{Si} = 97.9 \text{ nm}$ (400 nm)

Note, these are ***not*** the “thermal penetration depth”

REVIEW OF SCIENTIFIC INSTRUMENTS 87, 094902 (2016)

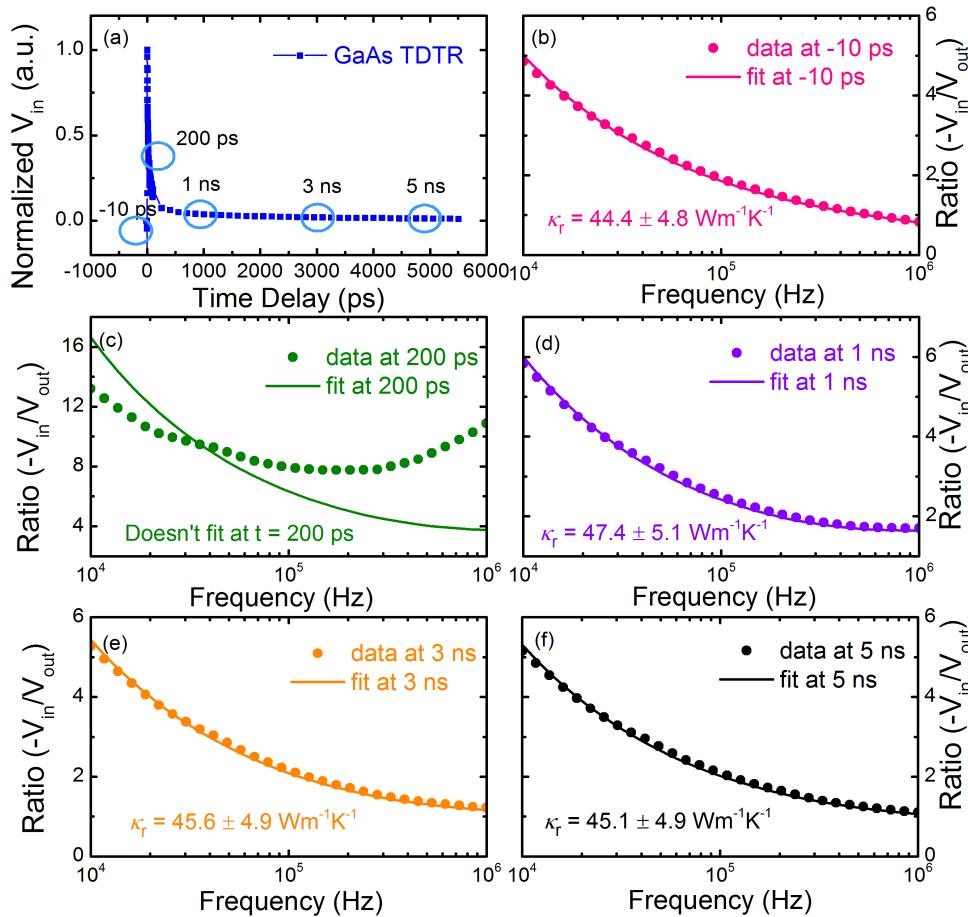
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Key Experimental Design

- Low modulation frequency: FDTR below 1 MHz
- Short plasma relaxation time: 400 nm pump, FDTR @ 5 ns delay

Must choose time to be greater than plasma relaxation time



From analysis of in-phase signal
and FDTR signal in tandem

$$\tau_{\text{GaAs}} \sim 400 \text{ ps}$$

Already studied in Si

50 ps – 2 ns

(JAP **82**, 4033 (1997))

(PRL **110**, 025901 (2013))

REVIEW OF SCIENTIFIC INSTRUMENTS **87**, 094902 (2016)

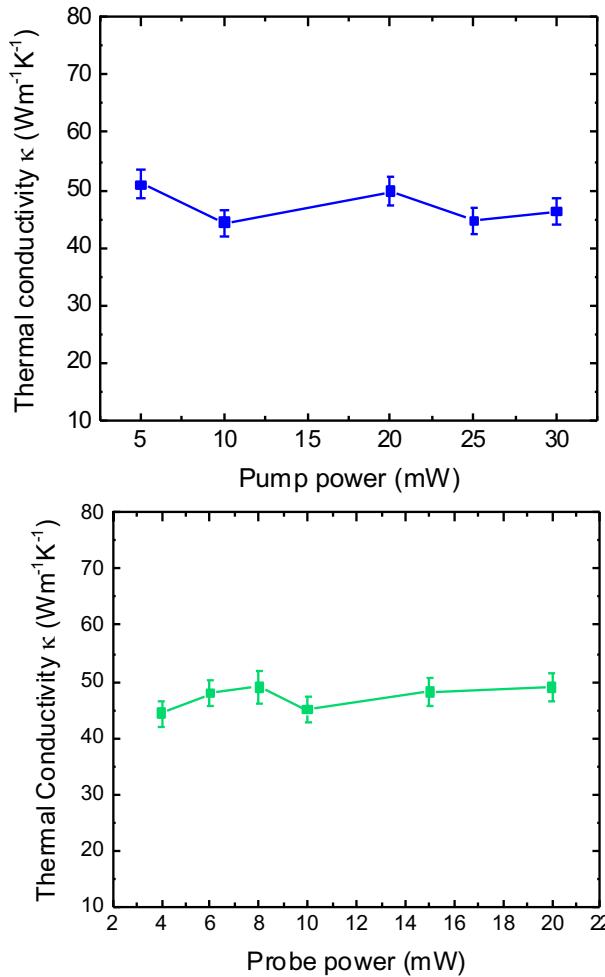
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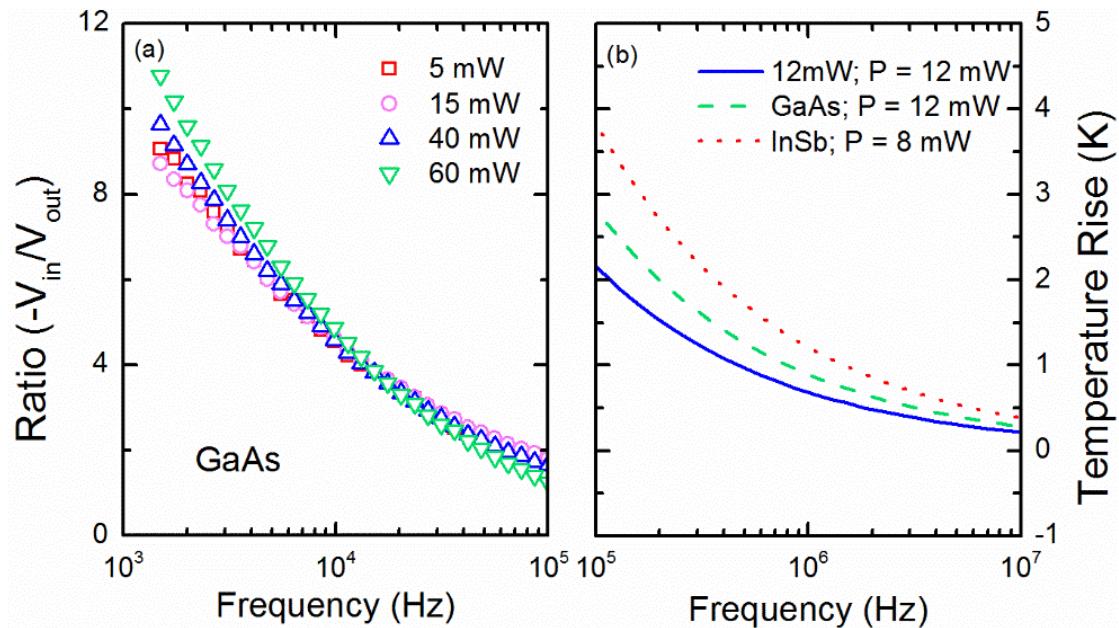
Key Experimental Design

- Low modulation frequency: FDTR below 1 MHz
- Short plasma relaxation time: 400 nm pump, FDTR @ 5 ns delay

Need to maintain “perturbative” ΔT



Both for assumption of:
1) constant properties
2) No temperature/fluence dependence in plasma decay

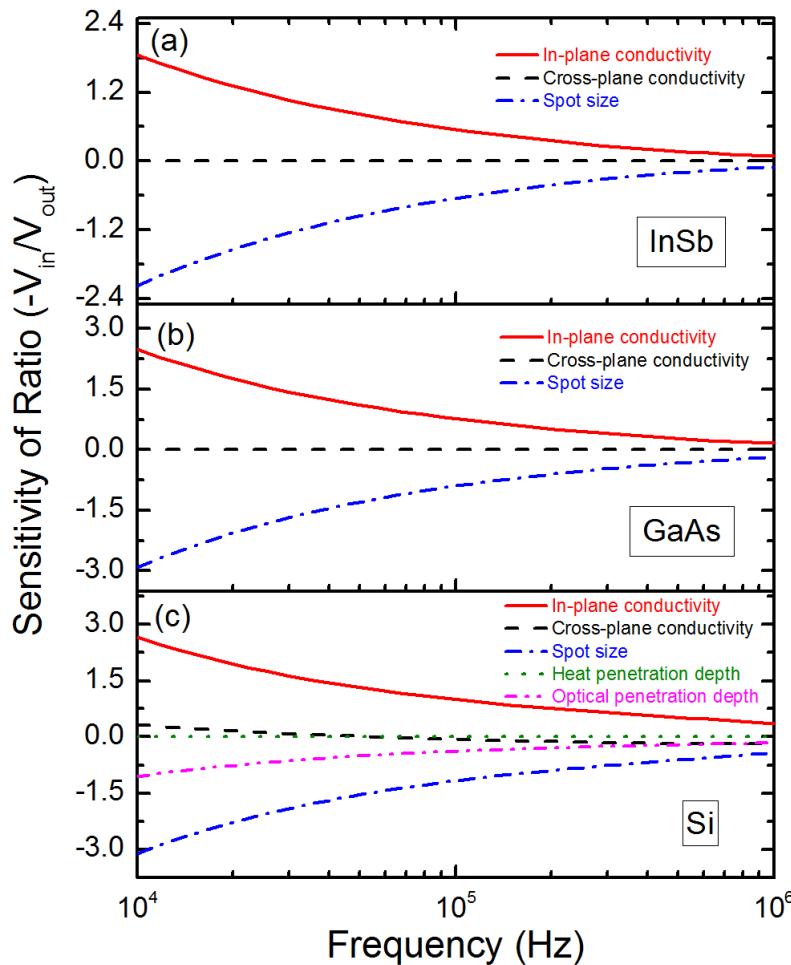


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So what are we measuring? What are we sensitive to?



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For bulk wafers, sensitive to:

- 1) In-plane thermal conductivity
- 2) Spot size
- 3) (to lesser extent) Optical penetration depth

For example

5% variation in both pump and probe spot sizes

=

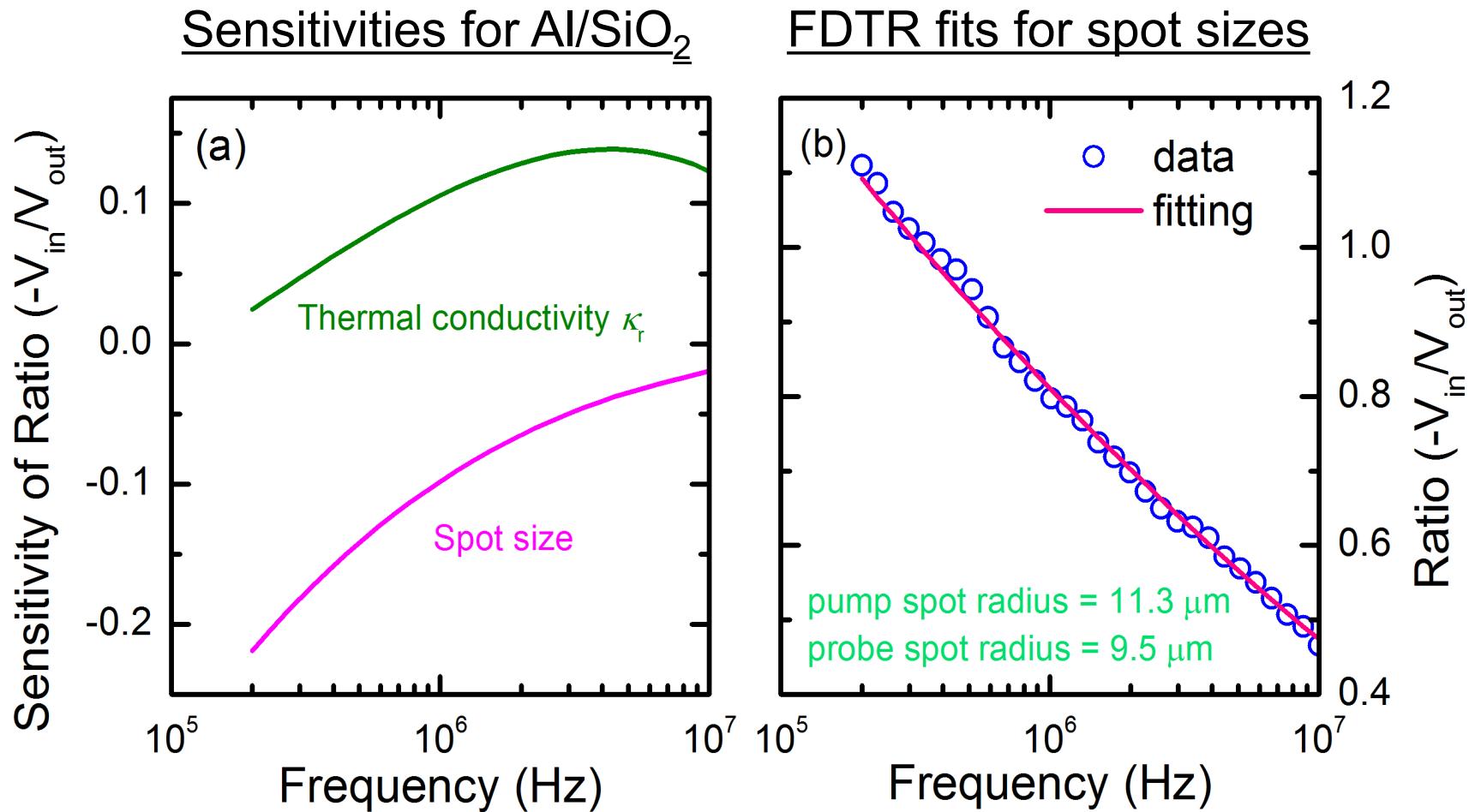
10% variation in κ

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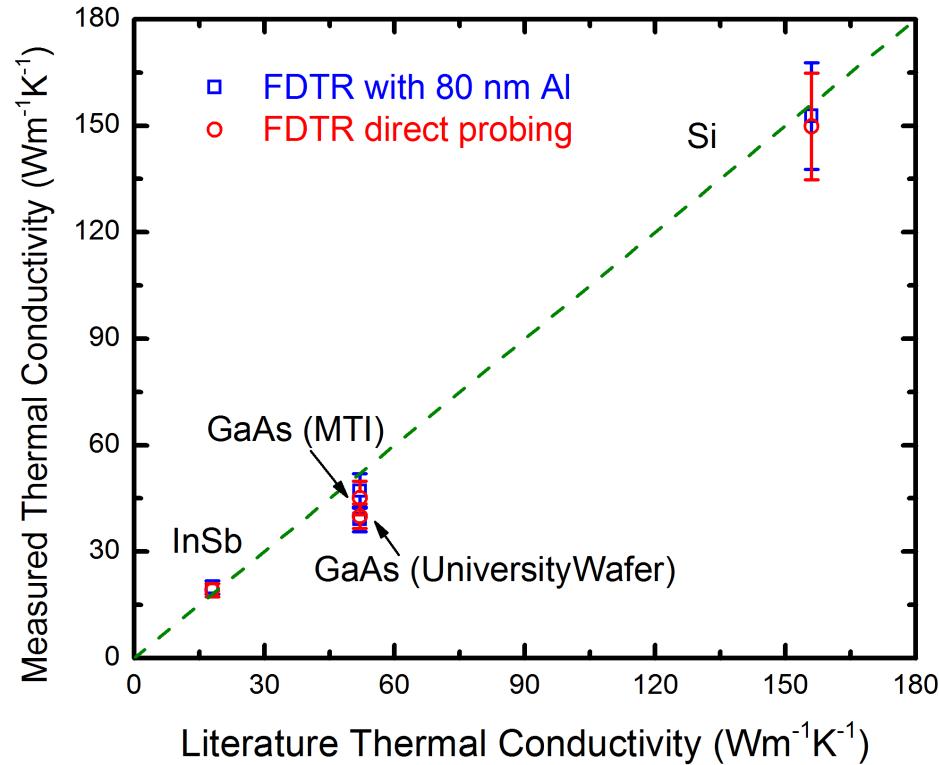
Should rigorously measure spot size “*in situ*”



All measurements and analyses at 5 ns where
large sensitivities to spot size in FDTR

Conclusions

- With understanding of plasma contribution, can use FDTR/TDTR w/o a transducer
- Keys: high energy pump (and probe), time delays after plasma relaxation, low frequencies
- Next steps: FDTR/TDTR at higher photon energies for pump and probe



REVIEW OF SCIENTIFIC INSTRUMENTS 87, 094902 (2016)

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